

<b>Notice of References Cited</b>	Application/Control No. 10/656,613	Applicant(s)/Patent Under Reexamination JOHNSON ET AL.	
	Examiner Kevin Quinto	Art Unit 2826	Page 1 of 1

U.S. PATENT DOCUMENTS					
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	D	US-			
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FOREIGN PATENT DOCUMENTS						
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NON-PATENT DOCUMENTS		
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	U	Wolf, "Silicon Processing for the VLSI Era: Vol. 1 – Process Technology, Lattice Press, 2000, 2 <sup>nd</sup> edition, p. 226
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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